



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

Group Art Unit: 1795

Application No.: 10/551,136

Examiner: S. ROSASCO

Filed: January 5, 2006

Docket No.: 125493

For: MASK BLANK, MANUFACTURING METHOD OF MASK BLANK,
MANUFACTURING METHOD OF TRANSFER MASK AND MANUFACTURING
METHOD OF SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 6, 2009 Office Action, the statutory period for reply being
extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.